



Docket No.: M4065.0139/P139-A
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Cem Basceri

Confirmation No.: 2413

Application No.: 09/633,132

Group Art Unit: 2815

Filed: August 4, 2000

Examiner: E. Lee

For: METHOD FOR IMPROVING THE
SIDEWALL STOICHIOMETRY OF THIN
FILM CAPACITORS

AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)

MS: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated August 11, 2003 (Paper No. 22), finally rejecting claims 39, 41-48, 50-56 and 74-83, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks begin on page 8 of this paper.

RECEIVED
JAN 20 2004
TECHNOLOGY CENTER 2800